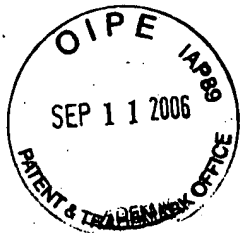


IN THE SPECIFICATION

Page 1, change the title according to the enclosed replacement sheet.



## REPLACEMENT SHEET

### IMPROVED PERMALLOY SENSOR

### PERMALLOY SENSOR HAVING INDIVIDUAL PERMALLOY RESIST PATTERN RUNNERS WITH LENGTHS PERPENDICULAR TO A WAFER LEVEL ANISOTROPY

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### FIELD OF THE INVENTION

The present invention relates in general to magnetic films and, more particularly, to permalloy films with increased sensitivity in low

10 field applications.